

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Jean-Michel Reynes et al GROUP ART UNIT: 2814  
APPLN. NO.: 10/518,158 EXAMINER: John C. Ingham  
FILED: December 10, 2004  
TITLE: POWER SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME

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Certificate of Submission

I hereby certify that this correspondence is being submitted to the U.S.P.T.O.,  
Alexandria, VA.

- ☐ Addressed per C.F.R. § 1.1(a) and deposited with the United States Postal  
Service with sufficient postage as first class mail.
- ☐ Facsimile transmitted in accordance with C.F.R. § 1.6(d).
- ☒ Submitted electronically via EFS in accordance with "Legal Framework  
for EFS Web".

4-19-07

\_\_\_\_\_  
Date of Submission

\_\_\_\_\_  
/Stacie Herrera/  
Signature

\_\_\_\_\_  
Stacie Herrera  
Printed Name of Person Signing Certificate

RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Final Office Action dated January 24 2007, and Examiner's comments  
with regard thereto, please enter the following statements in the above-entitled application,  
without prejudice or disclaimer, relative to the claims presently on file.

If Applicant has overlooked any fees, or if any overpayment has been made, the  
Commissioner is hereby authorized to credit or debit Deposit Account 503079.